

1560
PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Eric Bornstein
Application Serial No.: 10/649,910
Filing Date: 26 August 2003
Title: NEAR INFRARED MICROBIAL ELIMINATION LASER SYSTEM
Examiner: Shay, David M.
Art Unit: 3735
Confirmation No.: 5770
Atty. Docket No.: 072287-0019

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Date: 12 March 2007


Erin M. Olson

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TRANSMITTAL LETTER

Enclosed for filing in connection with the above-referenced patent application is an Information Disclosure Statement by Applicant, with a copy of the cited reference attached.

The Commissioner is authorized to charge the \$180 Information Disclosure Statement Fee, further fees which may be due and/or credit any over payment to Deposit Account No. 50-1133.

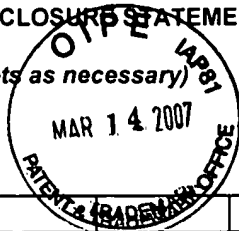
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Subst. for form 1449/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Complete if Known		
		Application Number	10/649,910	
		Filing Date	08/26/2003	
		First Named Inventor	Bornstein	
		Art Unit	3735	
		Examiner Name	Shay, David M.	
Sheet	1	3	Docket Number	072287-0019



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Examiner Initials	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ²			
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		Country Code ³ -Number ⁴ Kind Code ⁵ (if known)				
		WO 02/086550	10/31/2002	Haan et al.		
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Sheet	3	of	3	Docket Number	072287-0019
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		WO 2004/058352	07/14/2004	Palomar Medical Technologies, Inc.	
		WO 2006/076506	07/20/2006	Demetriou <i>et al.</i>	
Examiner Signature				Date Considered	

OTHER			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
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Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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